

IN THE U.S. PATENT AND TRADEMARK OFFICE
I N F O R M A T I O N S H E E T

jc011 U.S. PRO
10/024307
12/21/01

Applicant: TAKASHIMA, Masayuki
 UEDA, Kazumasa

Application No.:

Filed: December 21, 2001

For: POLISHING PAD, POLISHING APPARATUS AND POLISHING METHOD
 USING THE SAME

Priority Claimed Under 35 U.S.C. 119 and/or 120:

COUNTRY	DATE	NUMBER
JAPAN	12/28/00	2000-399684

Send Correspondence to: BIRCH, STEWART, KOLASCH & BIRCH, LLP
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The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

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